

IFW



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

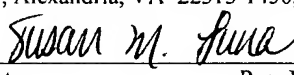
Application of

Applicant : Don Powell et al.
Serial No. : 10/706,415
Filed : November 12, 2003
Title : METHOD OF FABRICATING A SEMICONDUCTOR DEVICE
Docket No. : MIO 0060 V3 (98-0814.03)
Art Unit : 2818
Examiner : Dung A. Le

MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

CERTIFICATE OF MAILING	
I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on April 27, 2005.	
	
Agent	Reg. No. 38,769

AMENDMENT

This paper is being filed in response to the Office Action mailed March 14, 2005. Reconsideration and allowance of the application are respectfully requested in light of the amendments and remarks below.